



US00D737229S

(12) **United States Design Patent**  
**Masuda**

(10) **Patent No.:** **US D737,229 S**  
(45) **Date of Patent:** **\*\* Aug. 25, 2015**

(54) **SEMICONDUCTOR DEVICE**

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(\*\*) Term: **14 Years**

(21) Appl. No.: **29/481,535**

(22) Filed: **Feb. 6, 2014**

**Related U.S. Application Data**

(62) Division of application No. 29/389,545, filed on Apr. 13, 2011, now Pat. No. Des. 701,843.

(30) **Foreign Application Priority Data**

Dec. 28, 2010 (JP) ..... D.2010-031446  
Dec. 28, 2010 (JP) ..... D.2010-031447  
Dec. 28, 2010 (JP) ..... D.2010-031448

(51) **LOC (10) Cl.** ..... **13-03**

(52) **U.S. Cl.**  
USPC ..... **D13/182**

(58) **Field of Classification Search**  
USPC ..... D13/182  
CPC . H05K 1/0228; H05K 1/0245; H05K 1/0236;  
H05K 1/0263; H01L 21/02433; H01L 29/04  
See application file for complete search history.

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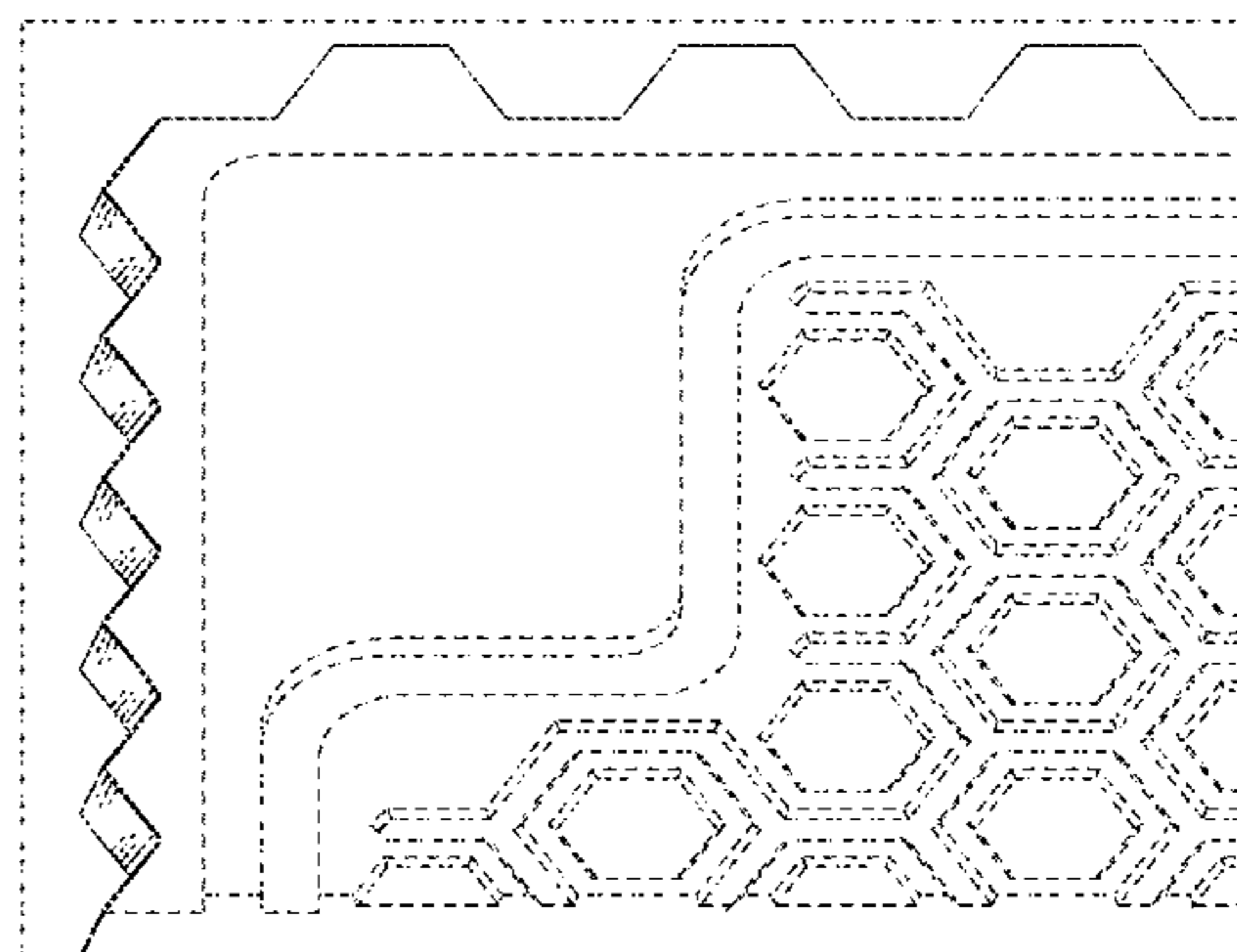
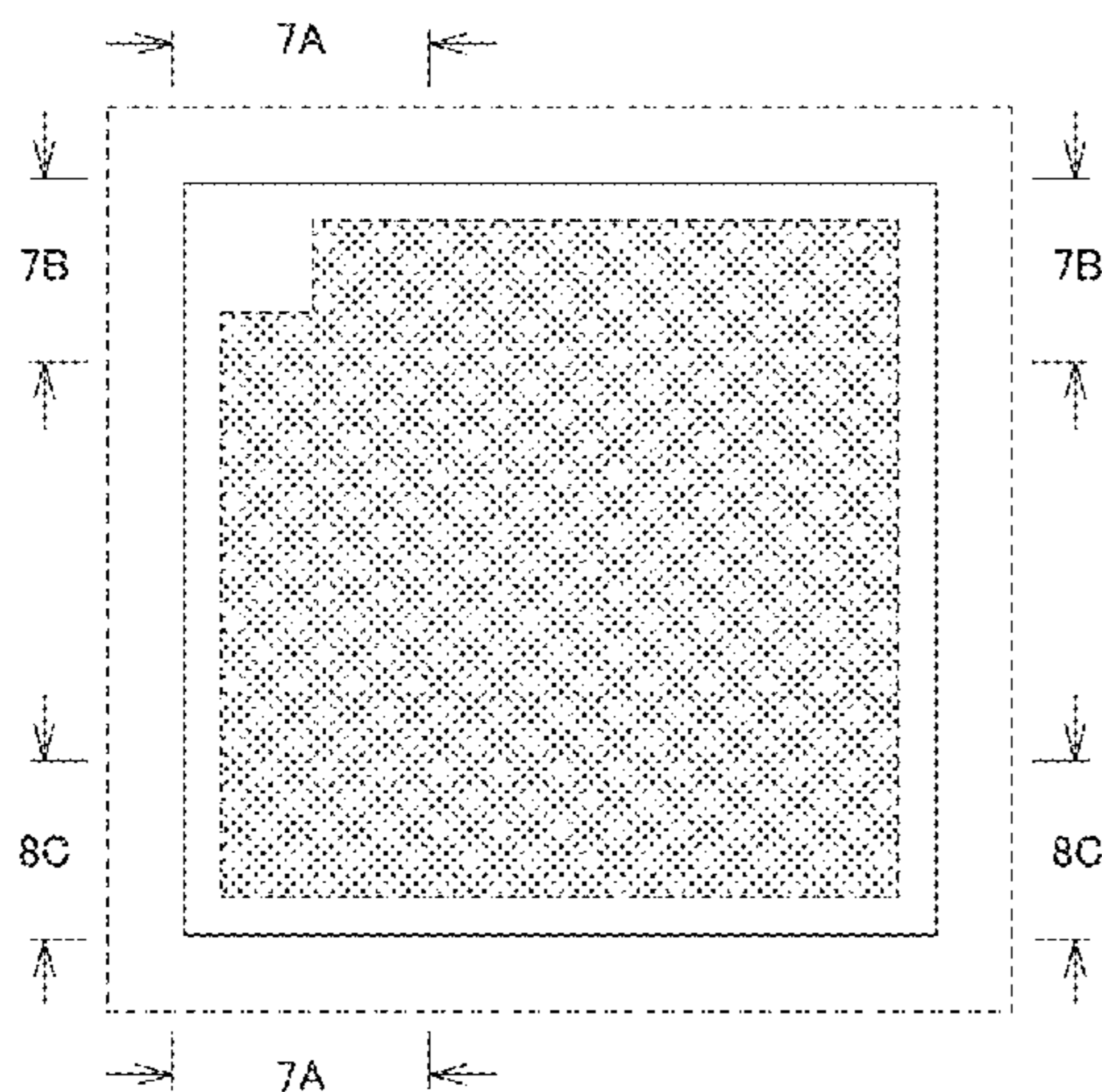
(57) **CLAIM**

The ornamental design for a semiconductor device, as shown and described.

**DESCRIPTION**

FIG. 1 is a front view of a semiconductor device showing my new design;  
FIG. 2 is a rear view thereof;  
FIG. 3 is a top plan view thereof;  
FIG. 4 is a bottom plan view thereof;  
FIG. 5 is a right side view thereof;  
FIG. 6 is a left side view thereof;  
FIG. 7 is an enlarged perspective view showing the area defined by indicia 7A and 7B of FIG. 1 thereof; and,  
FIG. 8 is an enlarged perspective view showing the area defined by indicia 7A and 8C of FIG. 1 thereof.  
The broken line showing is for illustrative purpose only and forms no part of the claimed design.

**1 Claim, 4 Drawing Sheets**



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FIG.1

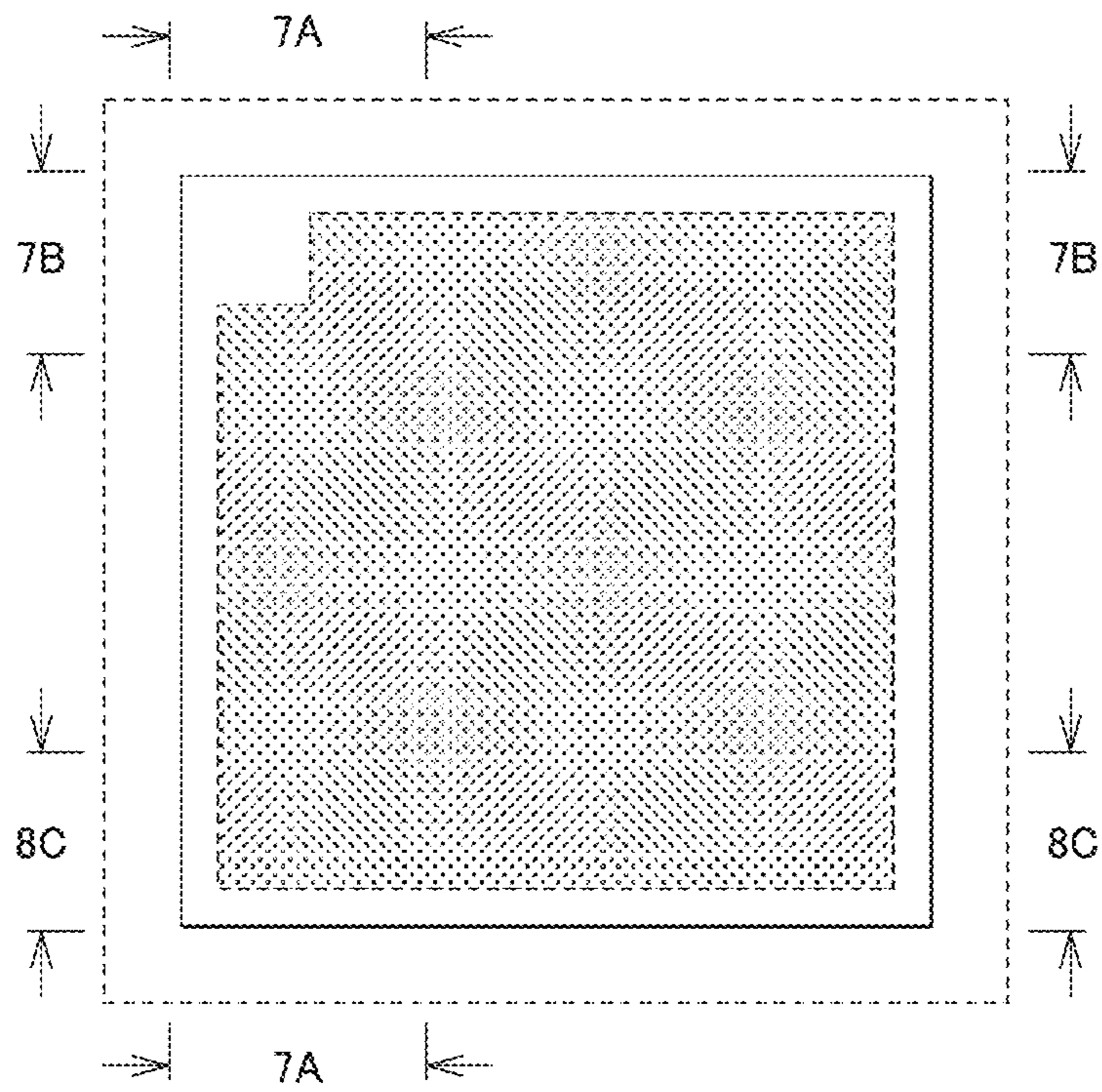


FIG.2

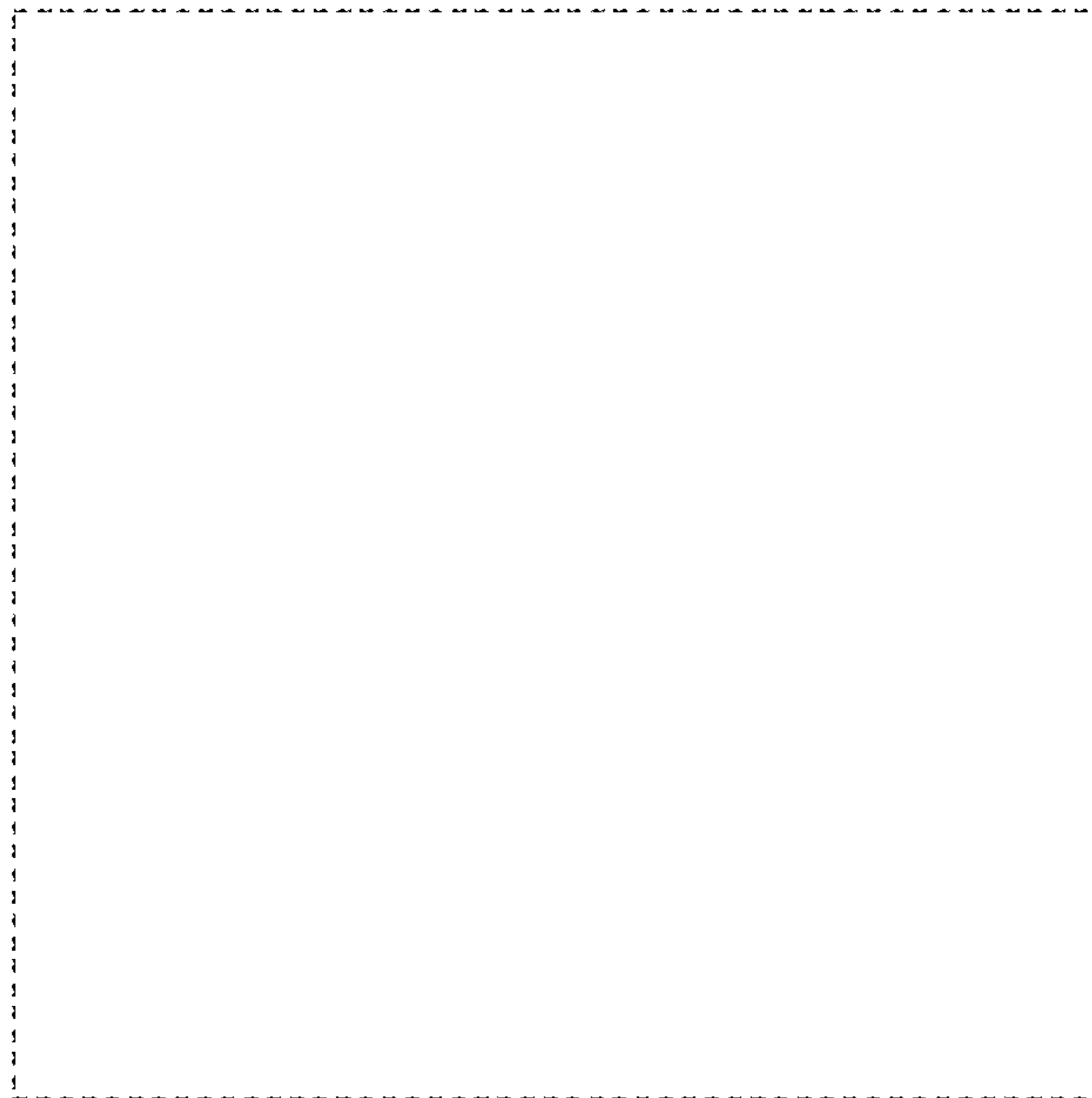


FIG.3



FIG.4



FIG.5

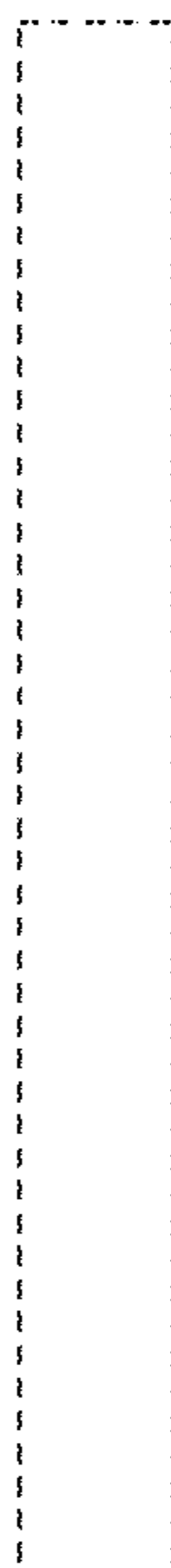


FIG.6

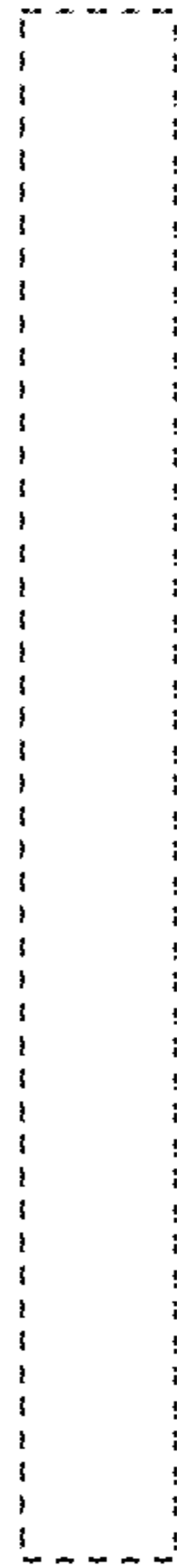


FIG.7

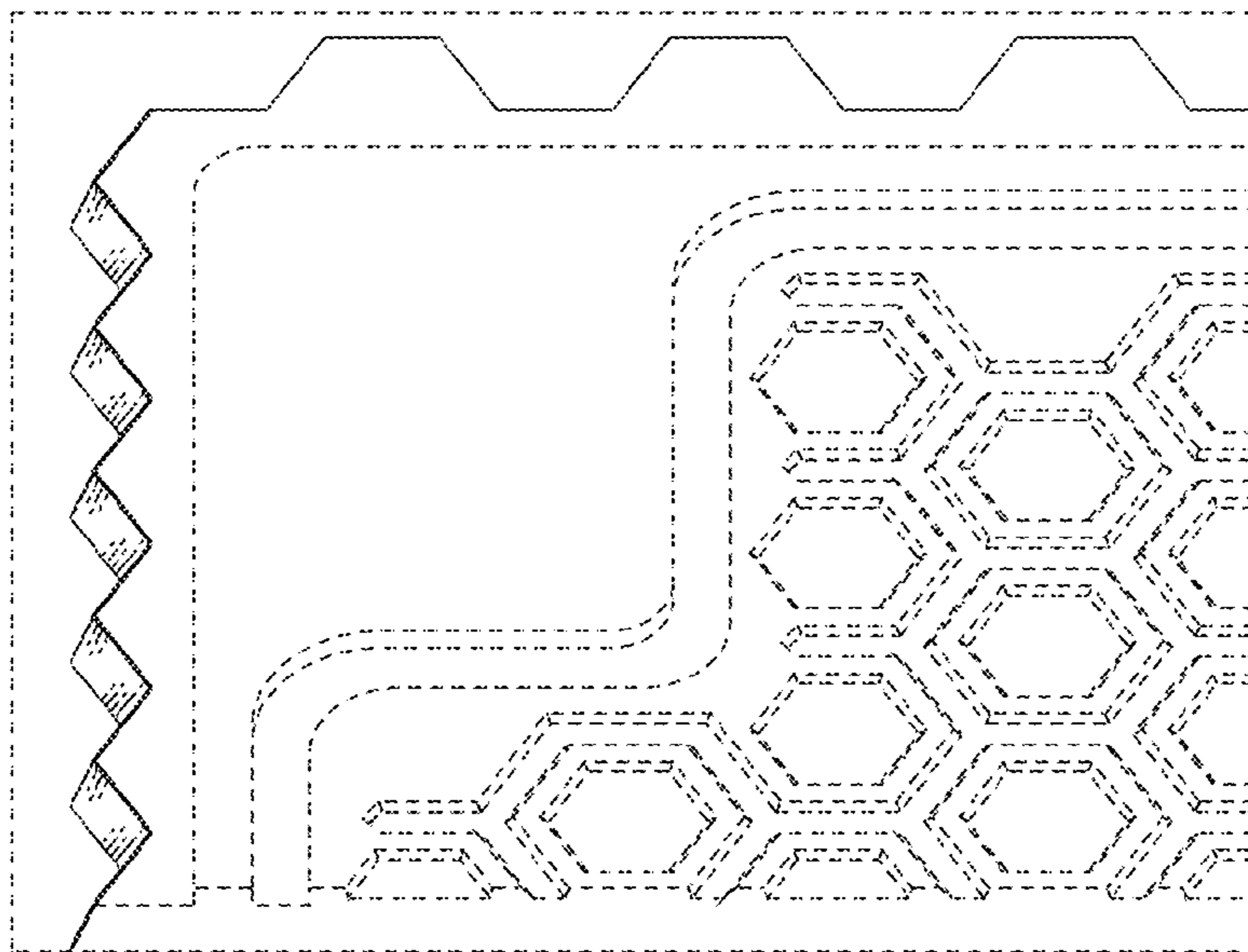


FIG.8

